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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Lin Docket No.: TSM02-0936
Serial No.: 10/649,310 Art Unit: 1756
Filed: August 27, 2003 Examiner: John S. Ruggles
For: Methods of Making Attenuated Phase-Shifting Masks from Mask Blanks

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RESPONSE UNDER 37 C.F.R. § 1.116

Applicant respectfully submits the following amendments and remarks in response to the Final Office Action dated May 15, 2006. Applicant respectfully requests that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of Claims 40-50 and 53.

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Response Under 37 C.F.R. § 1.116

PAGE 2/19 * RCVD AT 7/14/2006 6:33:56 PM [Eastern Daylight Time] * SVR:USPTO-EFXRF-5/0 * DNIS:2738300 * CSID:9727329218 * DURATION (mm:ss):04:38